KM steering and Dispersion bump simulation in RTML upstream of BC1 Kiyoshi Kubo (KEK) **ILC-LET** meeting, Daresbury 2007.01.10

Introduction

- Emittance preservation in "Old" RTML (no >10 km straight line), up to BC1 entrance
- Try to reproduce (check) results by P.Tenenbaum, presented in Valencia
 - Kick Minimization steering
 - Dispersion bumps
- And add
 - Coupling bumps
- Macro-particle tracking using computer code SAD

Kick Minimization

Quad magnet, BPM and steering magnets should be attached.

Minimize
$$r\sum_{i} (x_i^2 + y_i^2) + \sum_{i} [(\theta_{x,i} + k_i x_i)^2 + (\theta_{y,i} - k_i y_i)^2],$$

 $\theta_{x(y)i}$: Additional kick angle (additional to designed kick)
of steering at *i* - th quad
 $x(y)_i$: Offset from designed orbit at *i* - th quad
 k_i : K - value (inverse of focal length) of the *i* - th quad
 r : Weight ratio : (Quad - BPM offset)²/(Quad offset)²



Dispersion bumps

Knobs

4 skew quads at the end of turnaround

- (a) Set opposite strength of a pair of skew quads in turn around, -I between them.
- (b) Set opposite strength of another pair of skew quads in turn around, -I between them. 90 degree phase difference from the first pair.

Knob 1: (a) + (b)

- Knob 2: (a) (b)
- Monitors
- At the end of the beam line (before BC1)

Use three laser wire monitors (beam size monitors) at the end of the line (before BC1), 45 degree phase advance between two.

• Minimize projected emittance calculated from beam sizes at three locations.

Coupling bumps

- Knobs
- 4 skew quads added at n ear the end of the beam line.
- Each skew quad is a knob.
- Monitors

Same for dispersion bumps

Errors - same as PT's (at Valencia meeting), except beam size monitor

Tolerance Type	RMS Value	
Quad Misalignments (x,y)	150 um WRT survey line	
BPM Offsets (x,y)	7 um WRT quad center	
Quad Strength Errors	0.25%	
Bend Strength Errors	0.5%	
Quad Rotation	300 urad	
Bend Rotation	300 urad	
Beam size monitor	perfect, or 0.2 um	

Result of KM steering

Distribution without quad rotation

(Dominant source of emittance

(with other errors)

Final vertical emittance increase, 50 random seeds

increase is quad rotation.) 7 25 6 No Quad Rotation KN 20 Average: 4.8 nm 5 Average 22.8 nm 90%: 10.3 nm **Number of Entries** 90% CL 40.8 nm 15 4 3 10 2 5 1 0 $1 \, 10^{-8}$ 1.5 10⁻⁸ $2 \, 10^{-8}$ $2.5 \, 10^{-8}$ 5 10-9 6 10⁻⁸ 4 10⁻⁸ $2 \, 10^{-8}$ 8 10⁻⁸ 1 10⁻⁷ 0 $\Delta \gamma \epsilon_{v}(m)$ $\Delta \gamma \epsilon_{v}(m)$

KM is not effective for quad rotation errors. Not perfect even without quad rotation.

Result of KM steering - 2



Need several iteration of KM steering



Result of KM steering + Dispersion Bumps

Final vertical emittance increase, 50 random seeds



Result of KM steering + Dispersion Bumps + Coupling Bumps

Final vertical emittance increase,

50 random seeds,

Perfect beam size monitor and resolution 0.2 micron



Result of KM steering + Dispersion Bumps + Coupling Bumps

Final vertical emittance increase, 50 random seeds

Projected emittance and normal mode emittance



Result of KM steering + Bumps

Vertical emittance increase vs. s, average of 50 random seeds



Emittance increase

	This simulation	PT
KM steering		
Mean / 90%CL	23 / 41 nm	23 / 44 nm
+ Dispersion Bump		
Mean / 90%CL	6.4 / 14.2 nm	7.6 / 13.2 nm
+ Coupling bump		
Mean / 90%CL	3.6 / 8.0 nm	
Beam size resolution 0.2 μ m		
Mean / 90%CL	8.5 / 17.8 nm	
(Normal mode emittance)		
(Mean / 90%CL)	(1.7 / 3.1 nm)	

SUMMARY

- Result agreed with PT's simulation
- Beam size monitor resolution should be very small for good bump corrections. 0.2 um seems not good enough.
- Result is not satisfactory.
 - 8 nm emittance increase, 90% CL with perfect beam size monitors
 - Emittance budget 4 nm (5 nm?) in RTML
 - Normal mode emittance (need perfect coupling correction) is less than half of projected emittance after bump corrections. (It means coupling correction is far from perfect.) But not small enough. (means dispersion correction is also not good enough.)

Need more studies